



ISU  
AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Tongbi Jiang et al.

Serial No.: 10/689,471

Filed: October 20, 2003

For: A Method For Forming A Stencil  
(As Amended)

§  
§  
§  
§  
§  
§  
§  
§  
§  
§

Art Unit: 3729

Examiner: Minh N. Trinh

Docket: MCT.0015C2US  
97-0524.04US

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed November 8, 2004, please amend the above-referenced patent application as follows:

Date of Deposit: December 8, 2004

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

*Cynthia L. Hayden*  
Cynthia L. Hayden